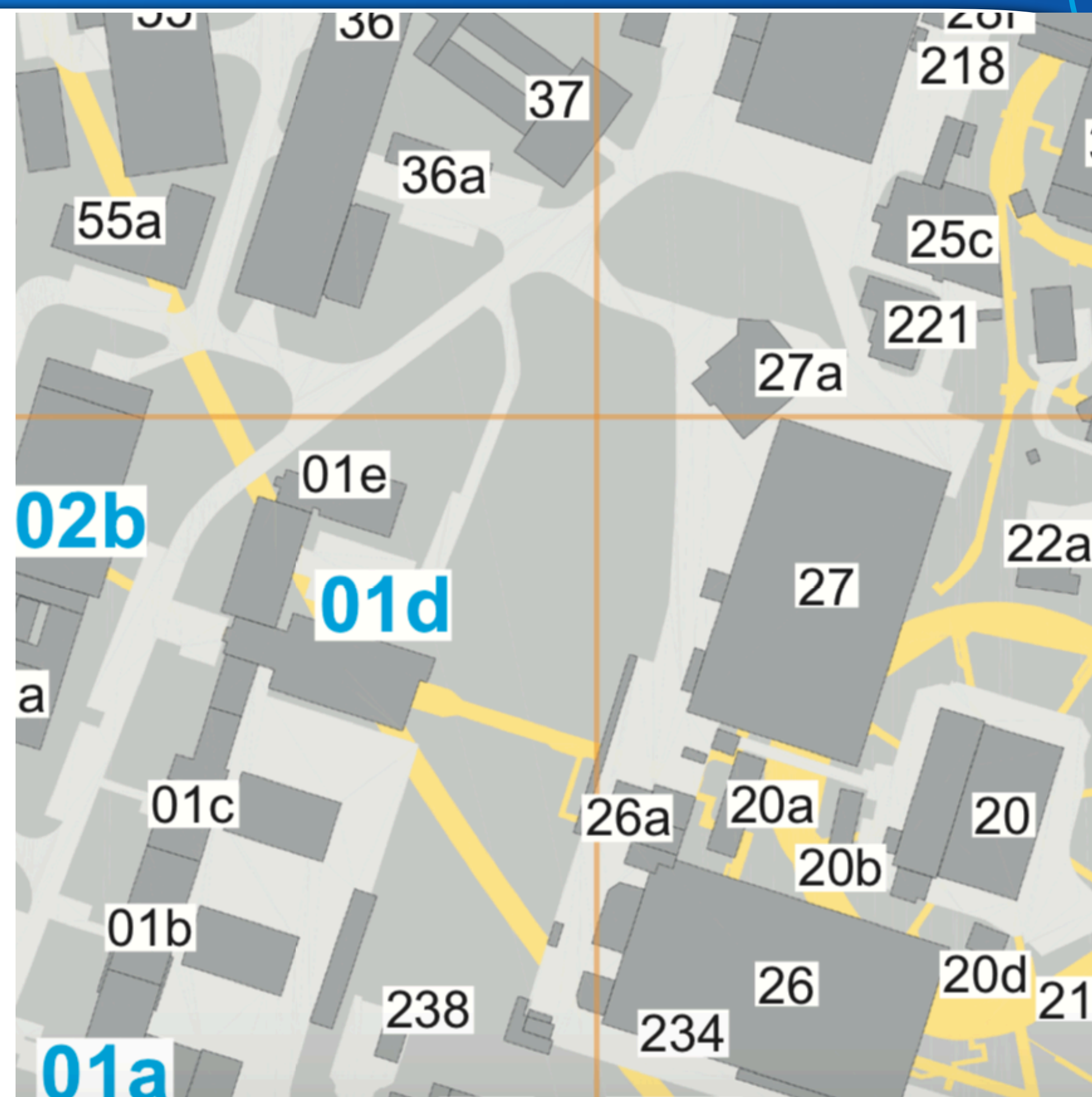


Track 1

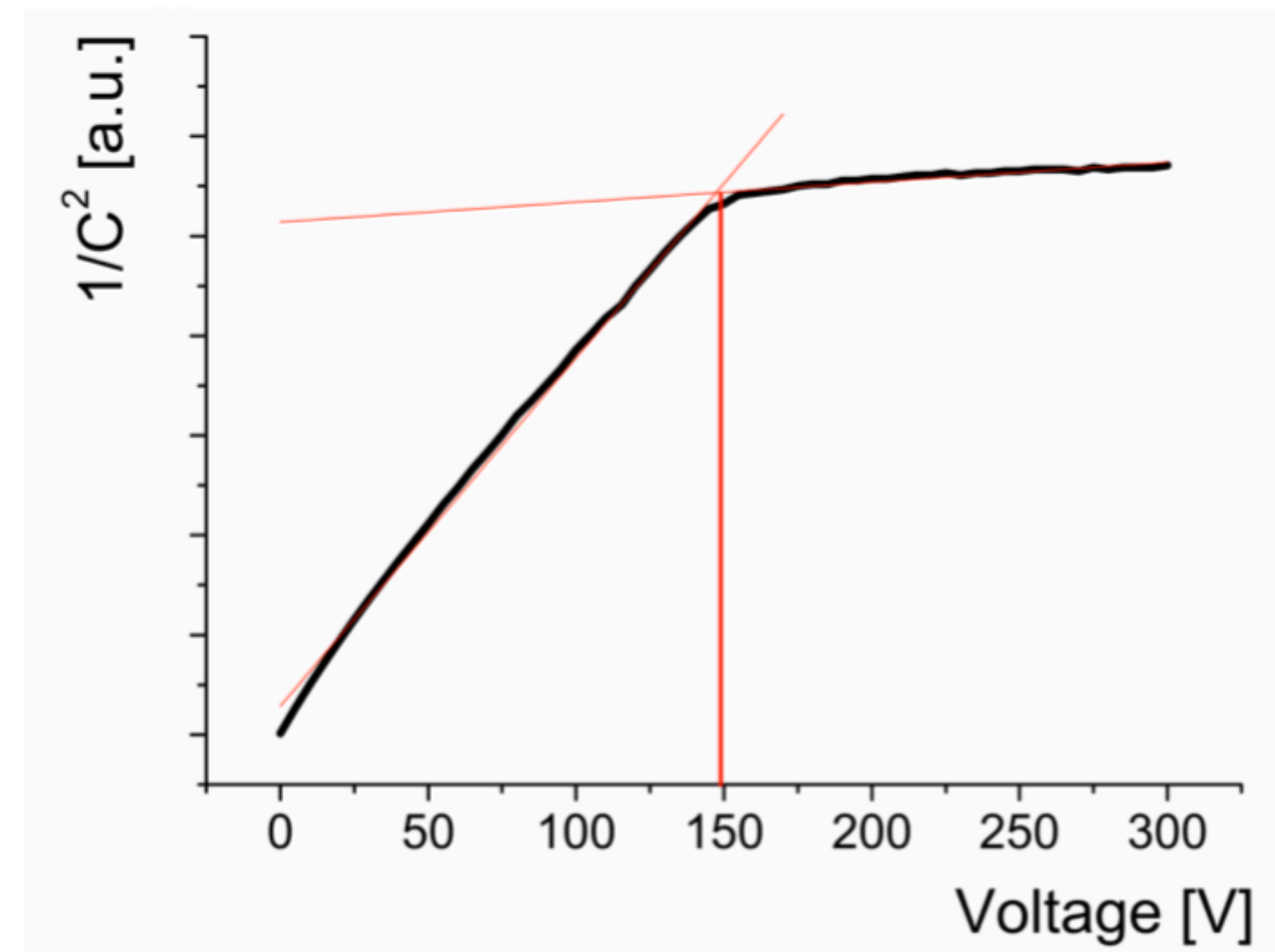
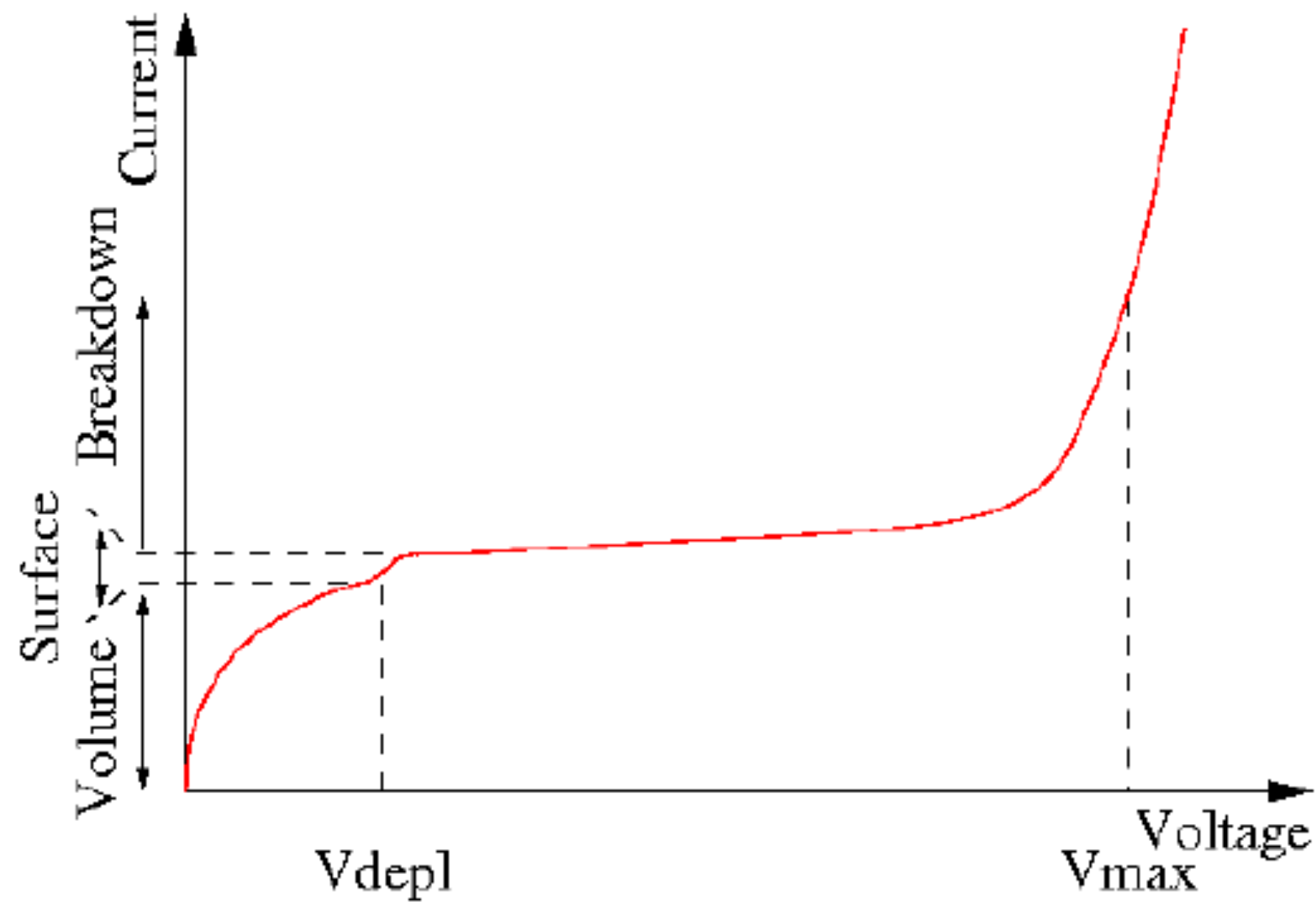
	Description	Location
Task 1	IV/CV characteristics	25c walk to another building
Task 2	Simulation with Weigthfield2	Seminar room 3a bring your laptop!
Task 3	Energy loss (ALiBaVa)	e-lab
Task 4	Charge mobility	e-lab



you will be picked up here and walk with task-supervisor to the venue

This task is about

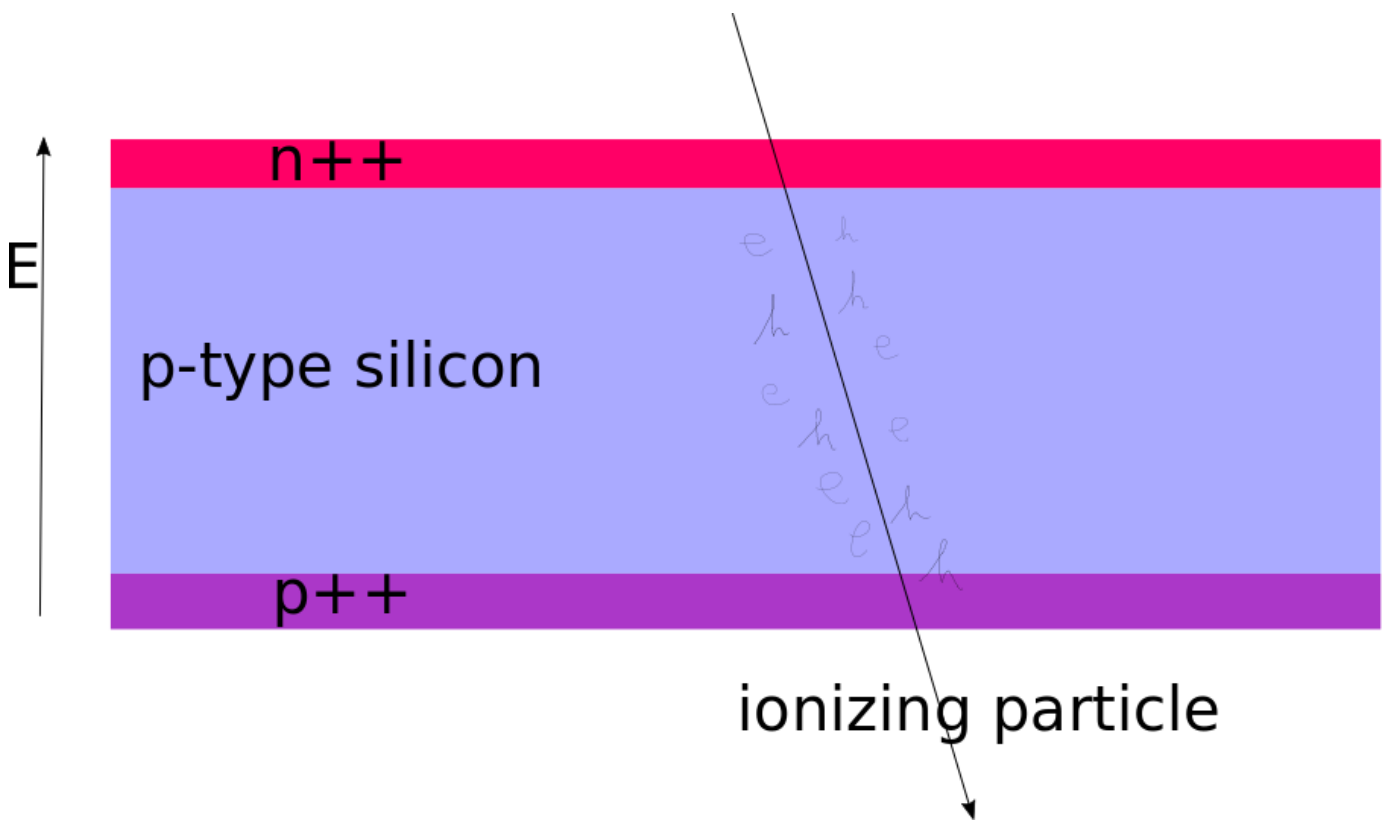
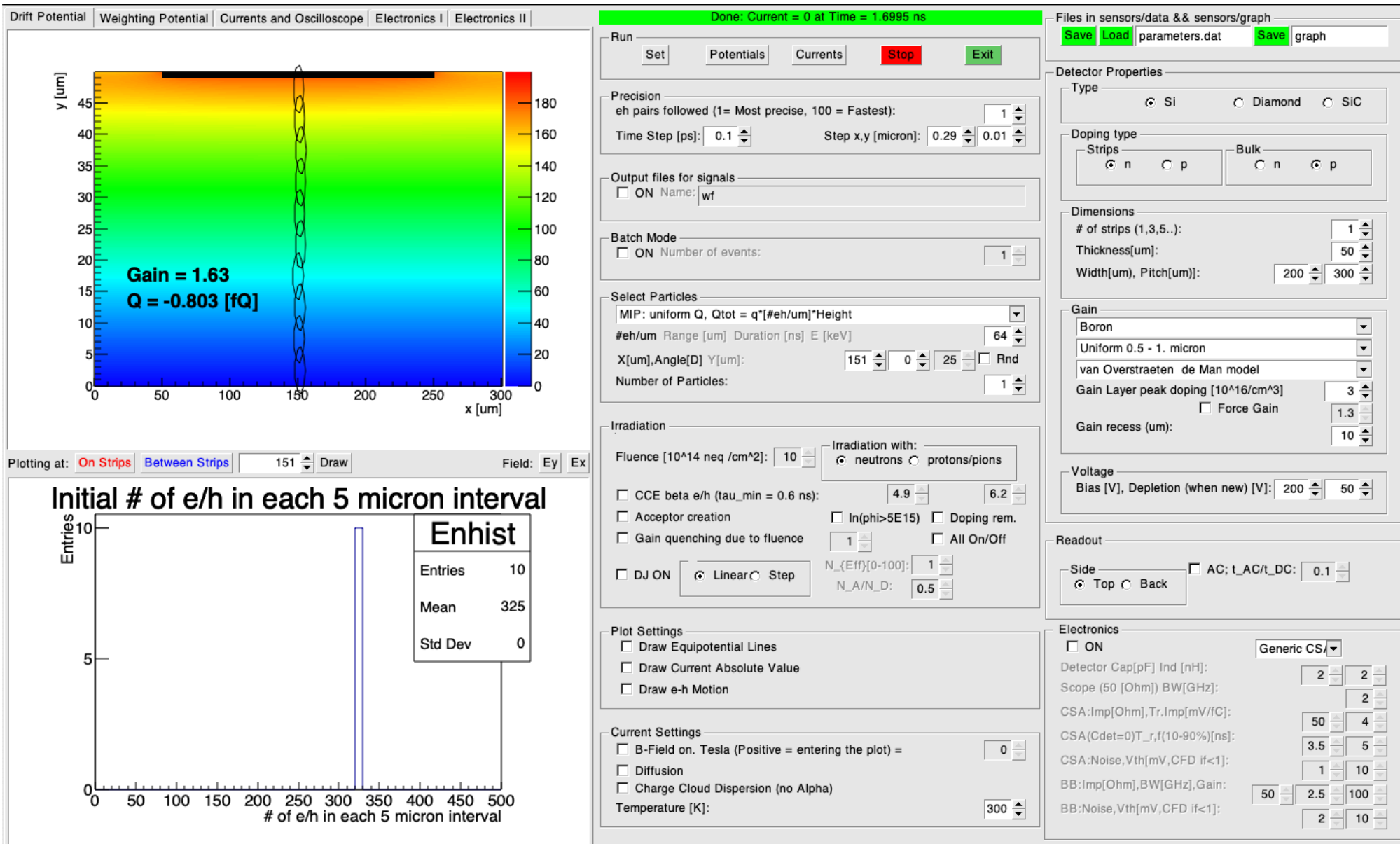
- the clean room (you get an introduction what we do there and why)
- handling of silicon test structures
- probe station
- simple characterisation of test structures



Task 2: Simulation with wakefield 2

- This task will simulate the behaviour of the silicon detectors with the weightfield simulation software. This software design silicon pads or strips and calculate the weight field for having the electrical field. After that, it can simulate the transient of particles such as MIPs, laser or alpha particles.
- The task will try to take a deep insight of the behaviour of silicon detectors using this software.

It shows a cross section of the detector

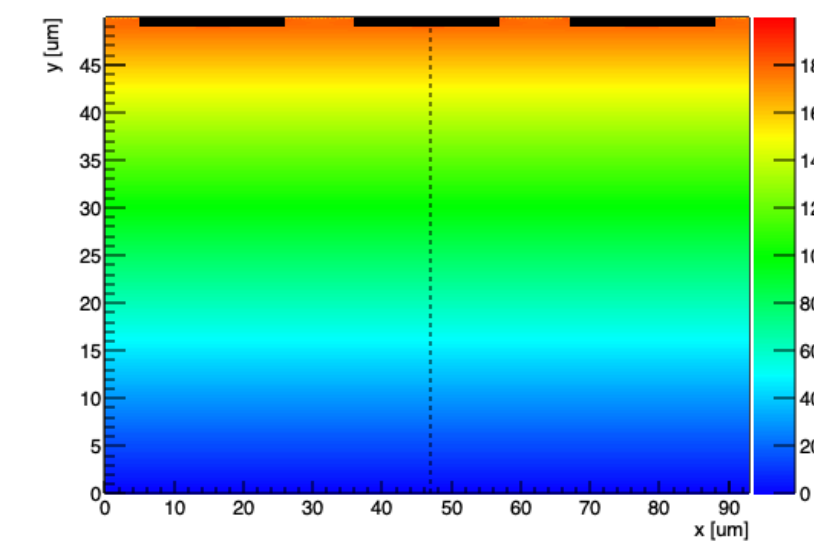


- Weight field was a tool designed by Ramo to calculate the electric field for a complex structures. What the Ramo theorem does, is to evaluate the induced current for a given electrode:

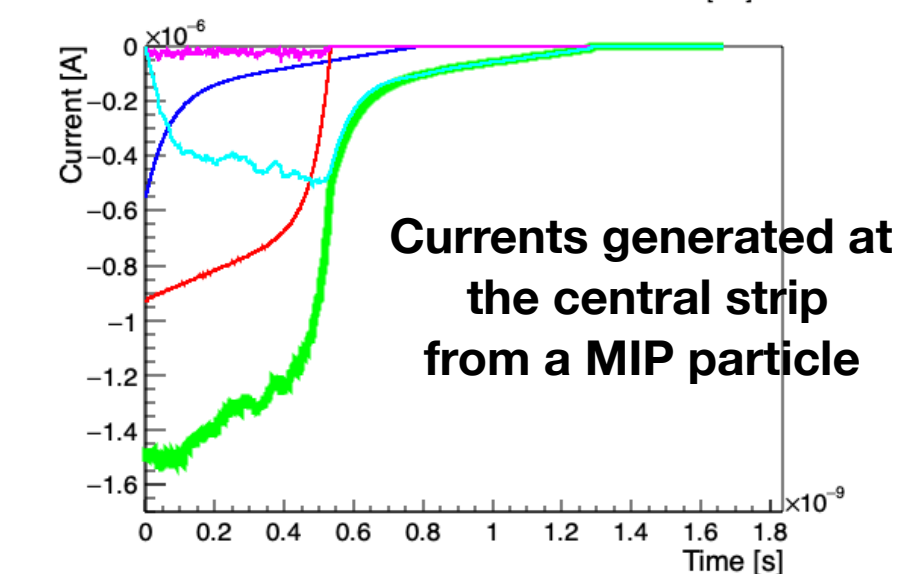
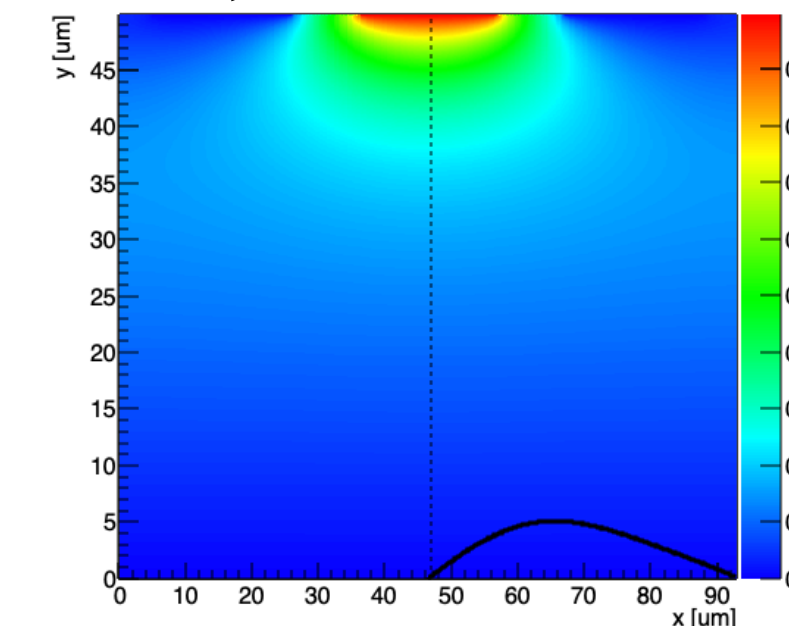
$$i = \overrightarrow{E_v} \cdot q \cdot \overrightarrow{v}$$

- the induced charge is $Q = q \cdot \Delta\phi_0$
- To find the weighting potential one should solve Laplace equation
 - $\nabla^2\phi = 0$
- Under the conditions:
 - 1. a chosen electrode is at $V=1V$
 - 2. The remaining electrodes are at $V=0V$
 - 3. The trapping state of charge is not taken into account

Three strips simulation

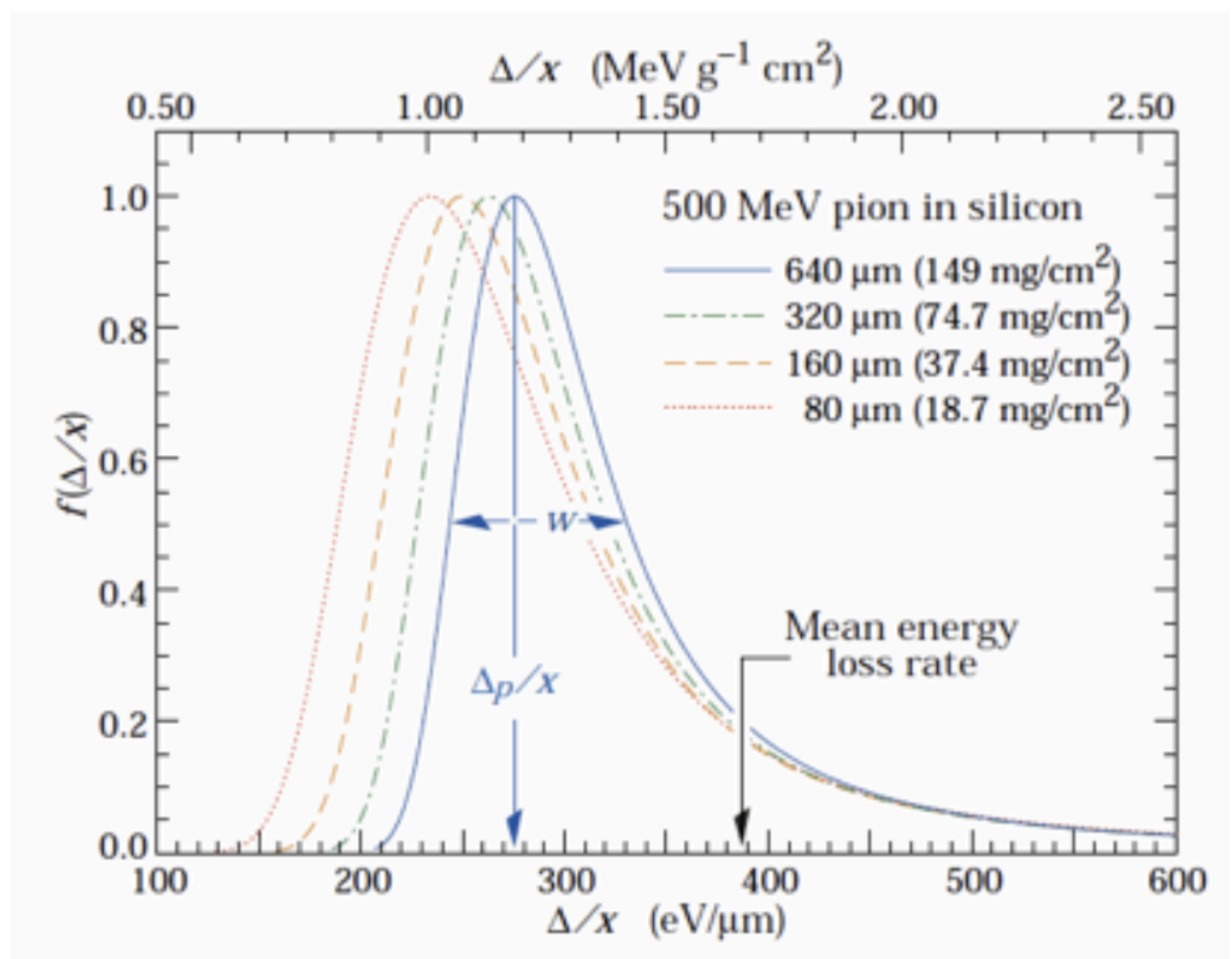
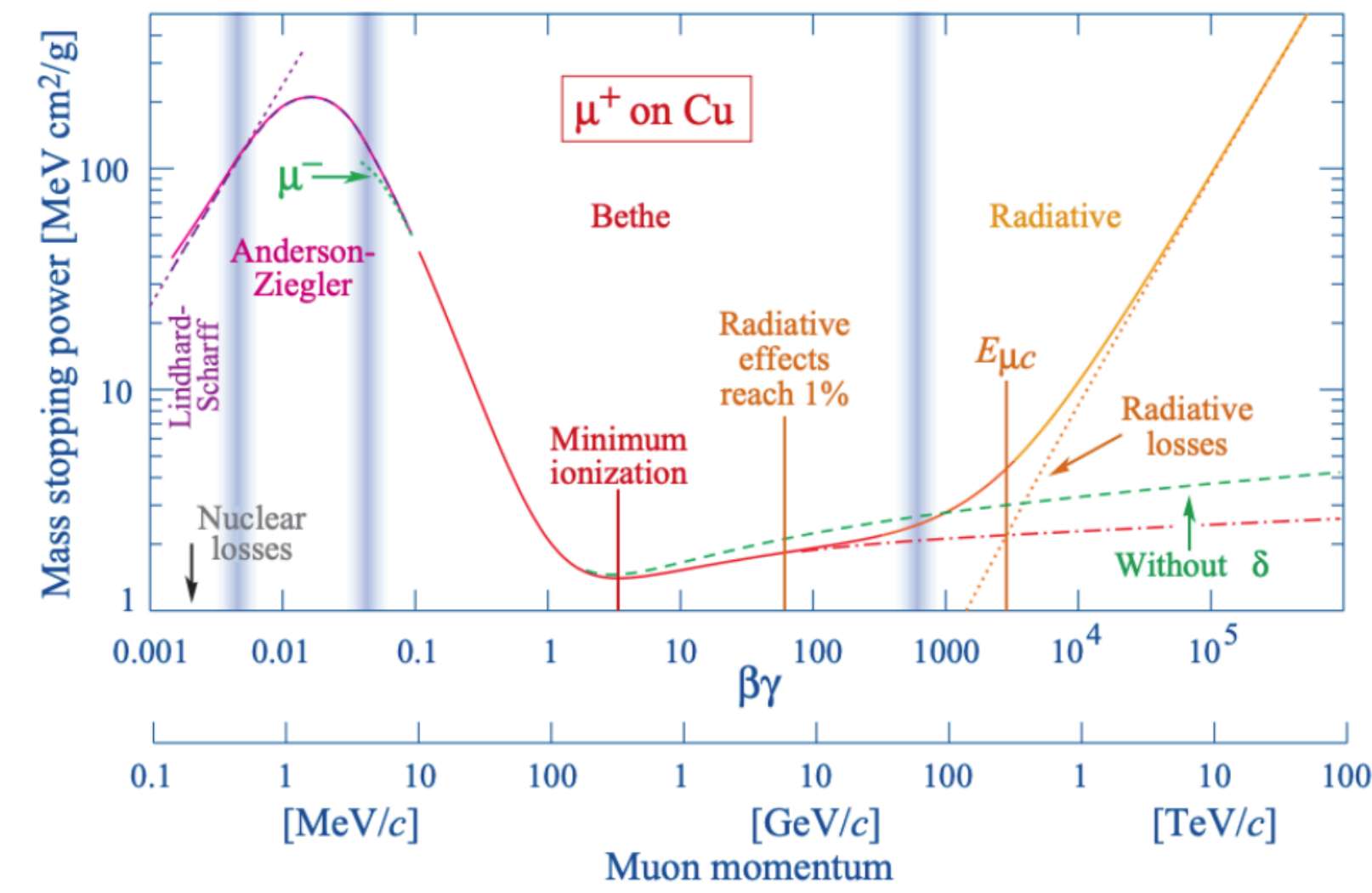
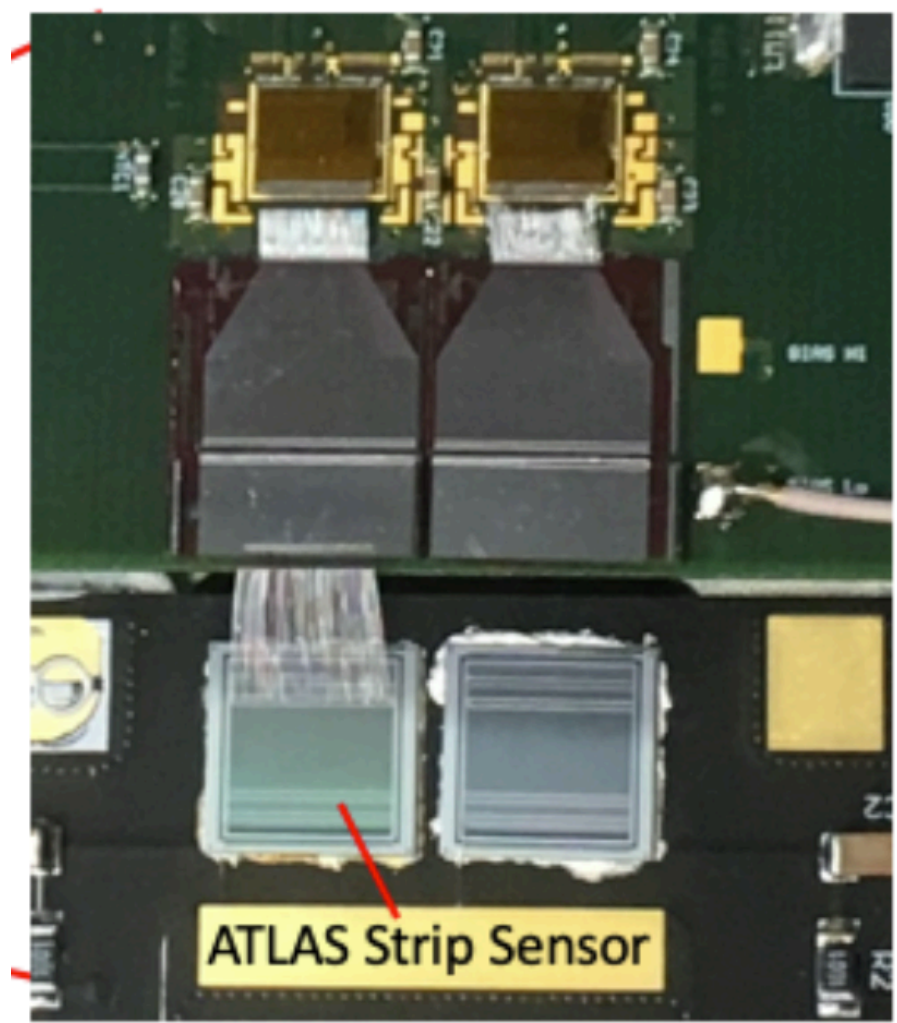
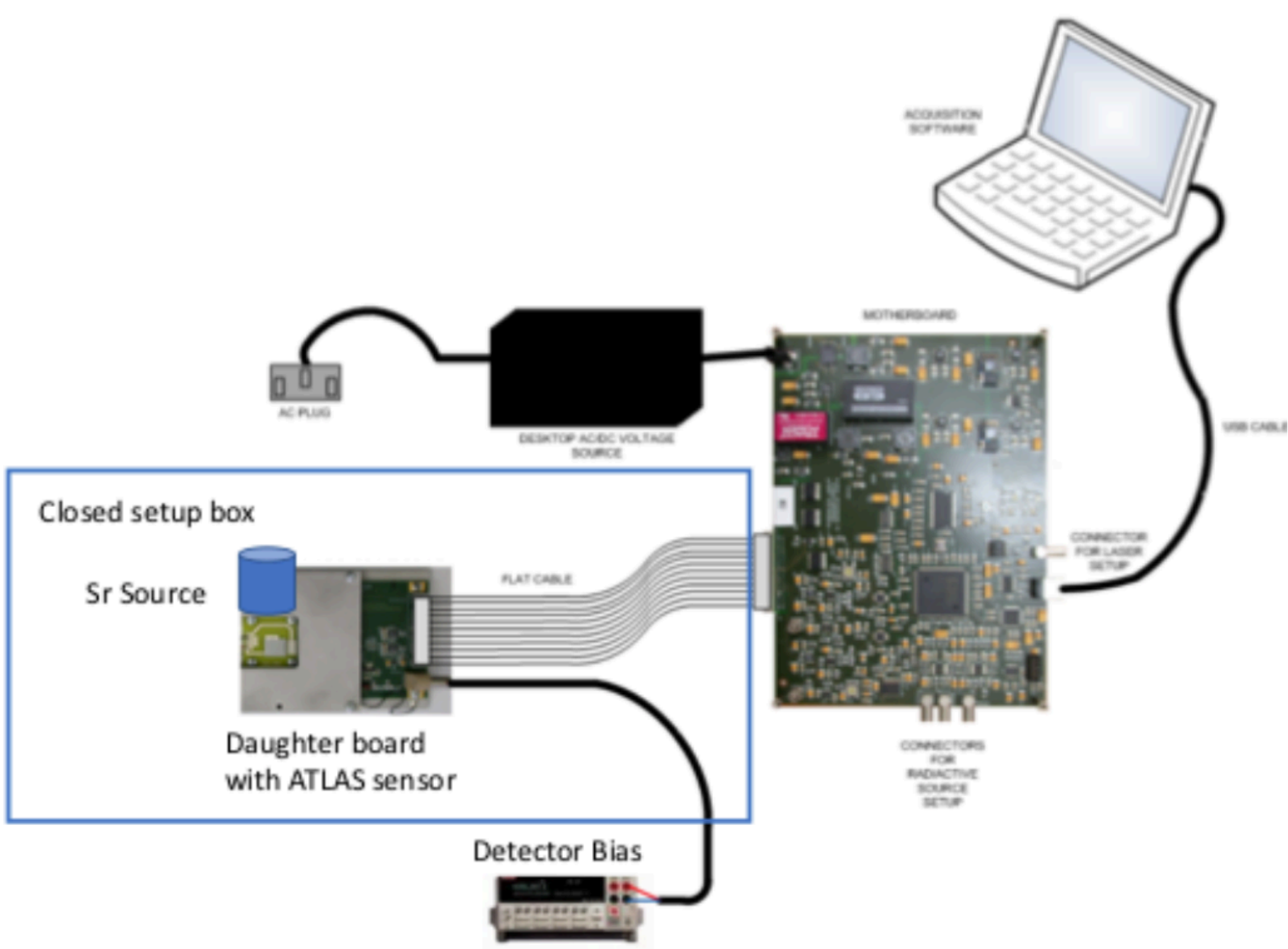
Weight field simulation,
the central strip

has 1V, the other electrodes 0V

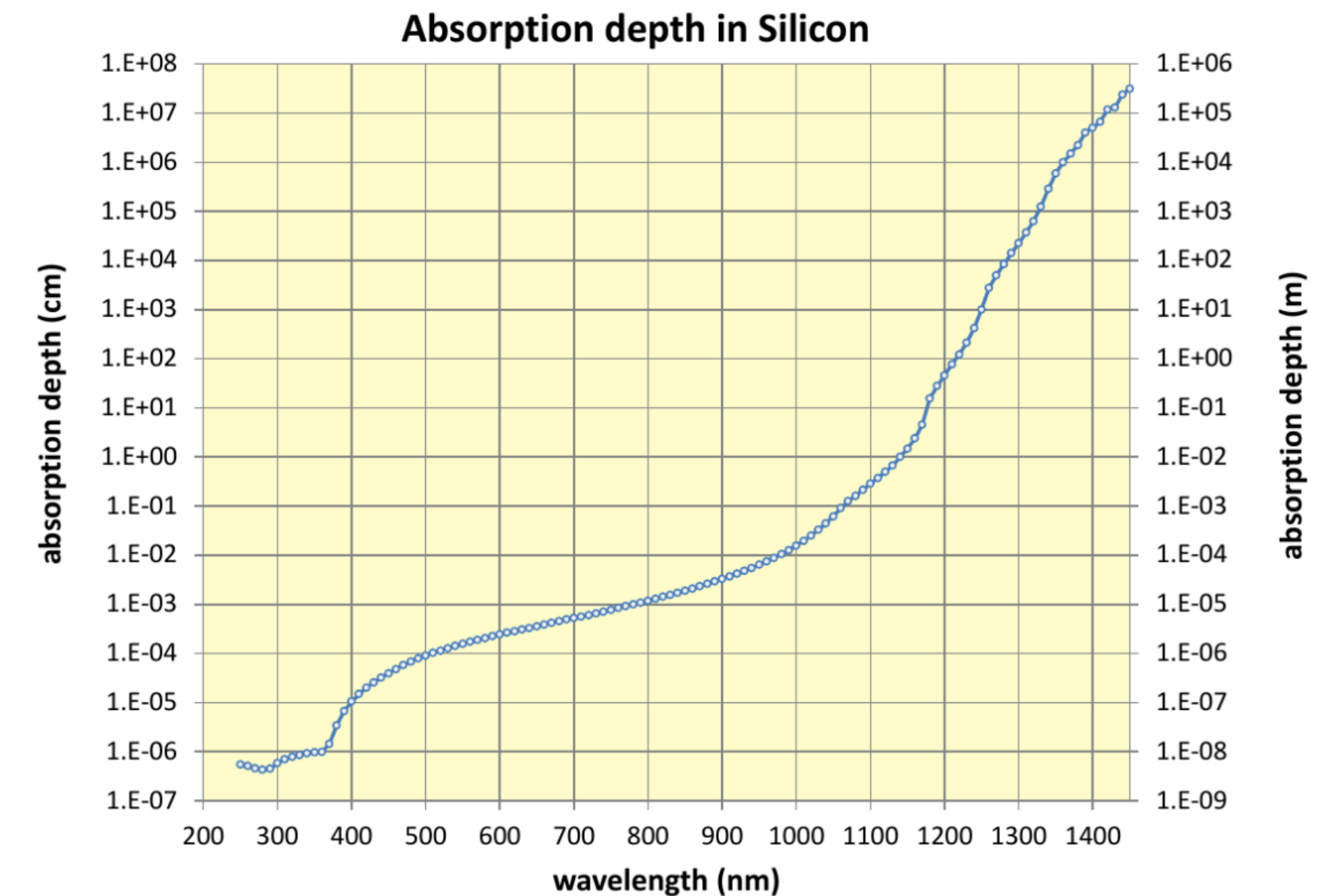
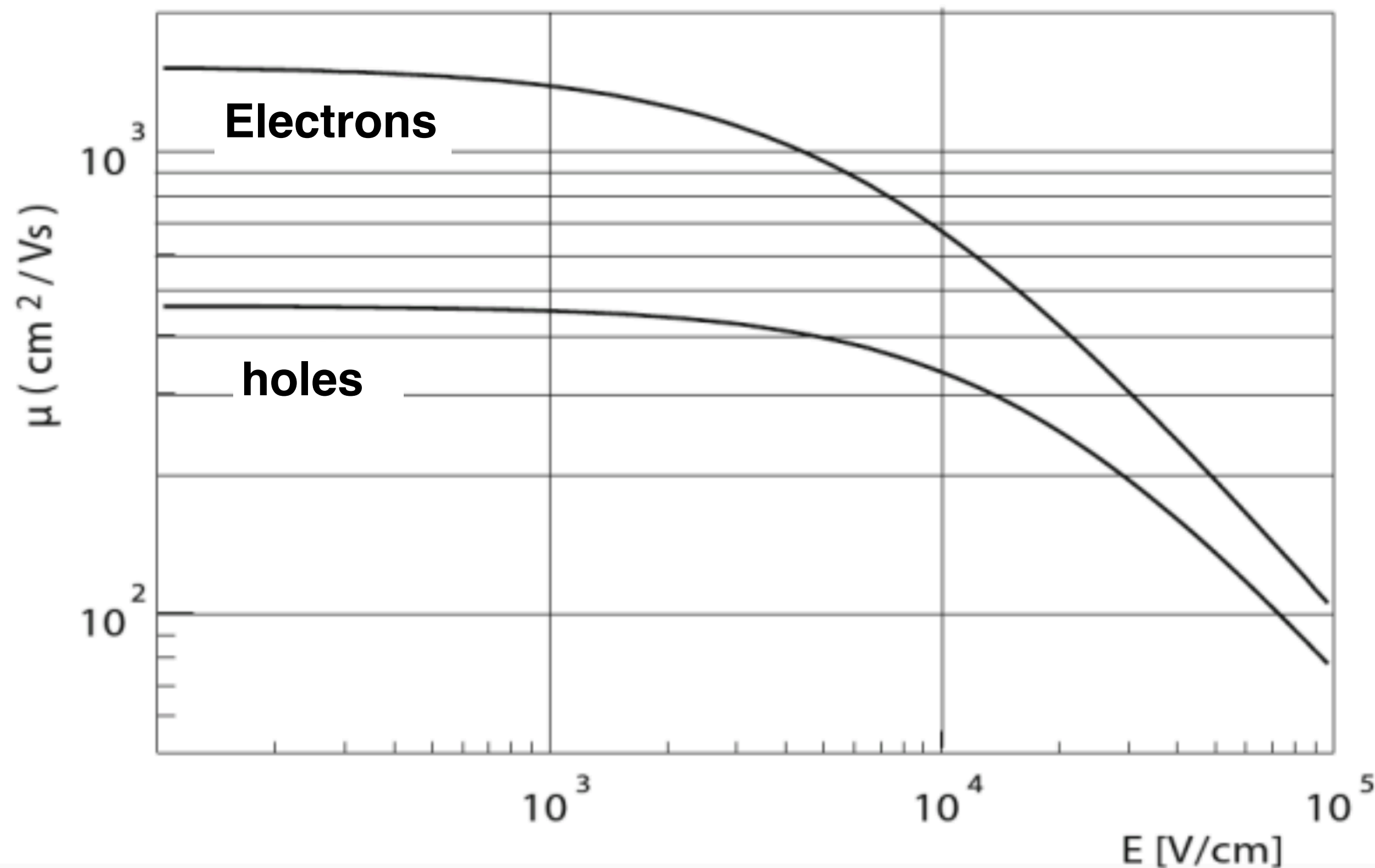


Task 3: Energy loss (Alibava)

Measurement of energy loss in silicon using a setup with analogue readout and measuring betas from a radioactive source (Sr90)



- Lasers will be used to inject charge carriers in silicon sensors
- A TCT setup will be used to record the induced signals
- electron/ hole collection, mobility, penetration depth of light in Si,...



Enjoy!

...and do it yourself!